

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Application of: |) |
| Applicant: John L. Fulton et al. |) Art Unit: 1709 |
| S. N.: 10/783,249 |) Examiner: Nicole R. Blan |
| Filed: 02/19/2004 |) Confirmation No: 1416 |
| For: PROCESS AND APPARATUS FOR |) Our Ref. No: 14138-B |
| REMOVING RESIDUES FROM |) Date: 4/18/2007 |
| SEMICONDUCTOR SUBSTRATES |) |

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

RESTRICTION/ELECTION/
PRELIMINARY AMENDMENT

Sir:

Responsive to the Office Action dated 03/30/2007, Applicant submits the following:

Amendments to the Specification begin on page 2.

Listing of Claims begins on page 3.

Remarks begin on page 13.